



MKI Cool

Miguel Diaz Zumel

Acknowledgements:

M.J. Barnes, C. Bracco, W. Bartmann, O. Bjorkqvist, L. Ducimetière, B. Goddard, T. Kramer, T. Maurin, V. Namora, A. Porret, T. Stadlbauer, P. Trubacova, L. Vega Cid, V. Vlachodimitropoulos, W. Weterings

Uppsala – September 19th to 22nd 2022

Outline

1. Context

- MKI purpose and design
- Cr₂O₃ coating
- Damping element and MKI cool

2. Issues – now solved

- HV breakdowns
- Unsuccessful conditioning

3. Issue – understood

- Mis-manufactured alumina tubes
- Present work

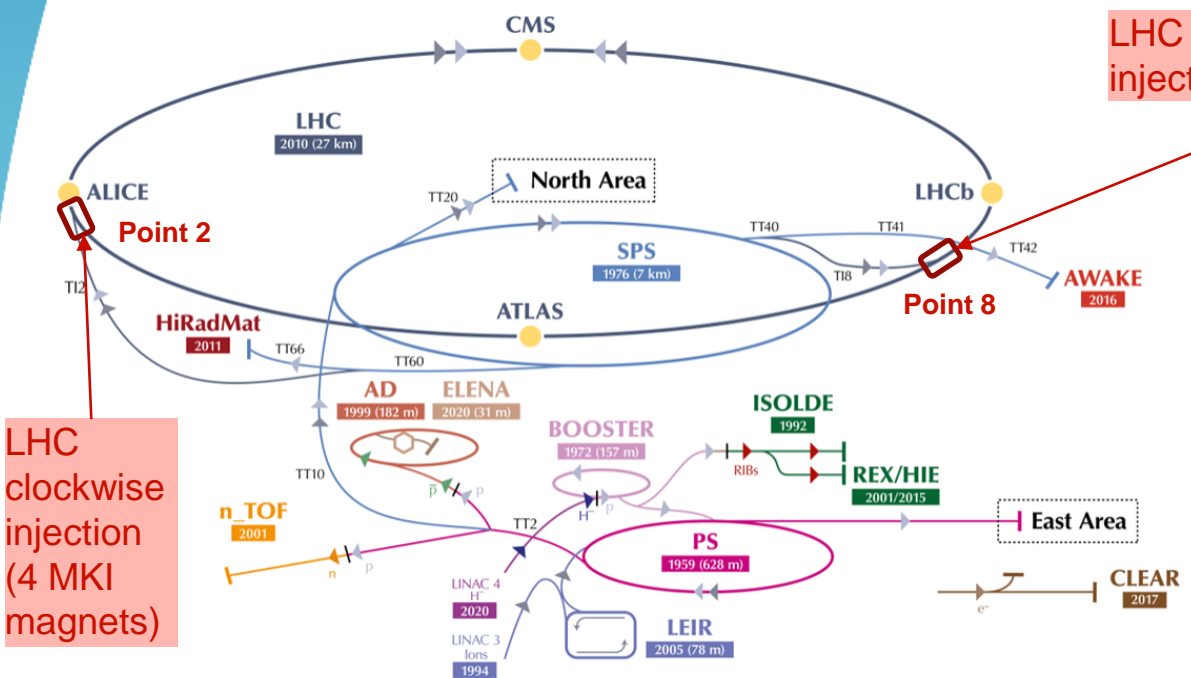
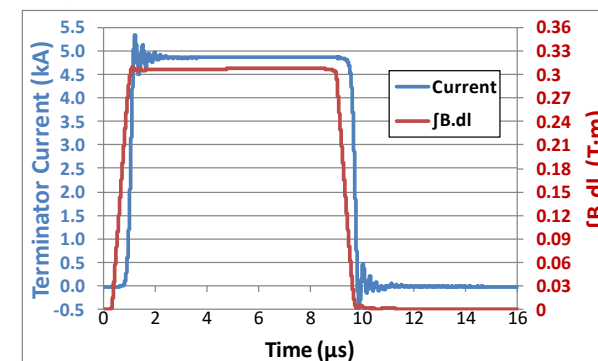
4. Status of first MKI cool to be installed in LHC

5. Conclusions

1. Context

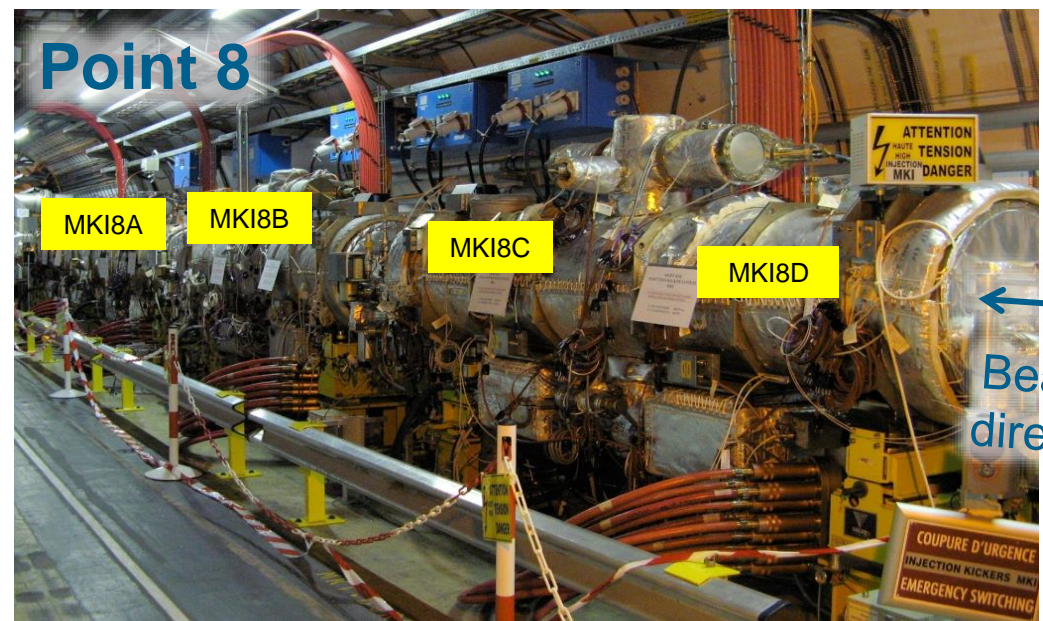
MKI: Injector kicker magnets for the LHC

Typical MKI pulse



LHC anti-clockwise injection (4 MKI magnets)

LHC clockwise injection (4 MKI magnets)



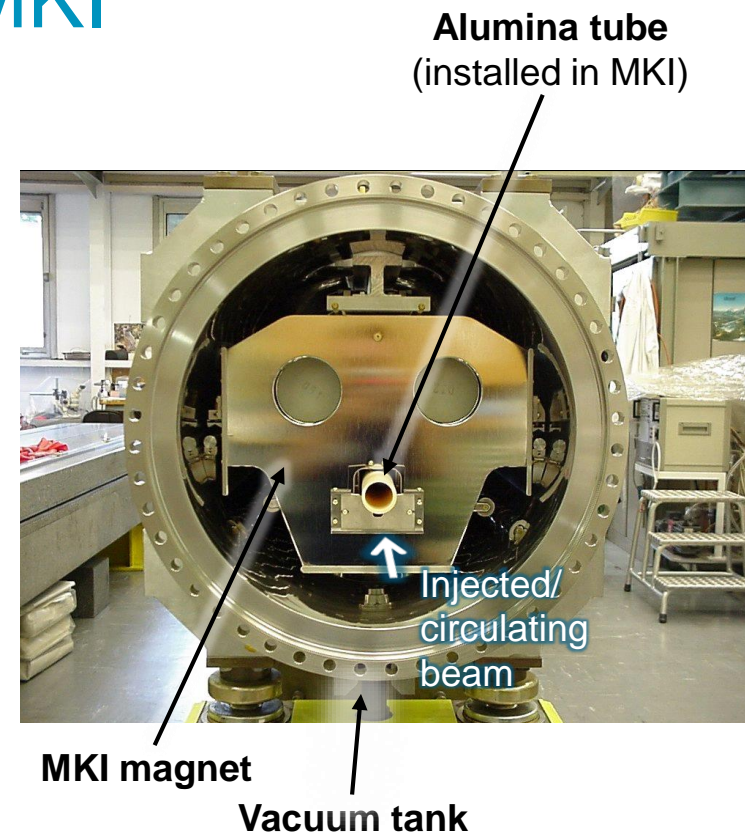
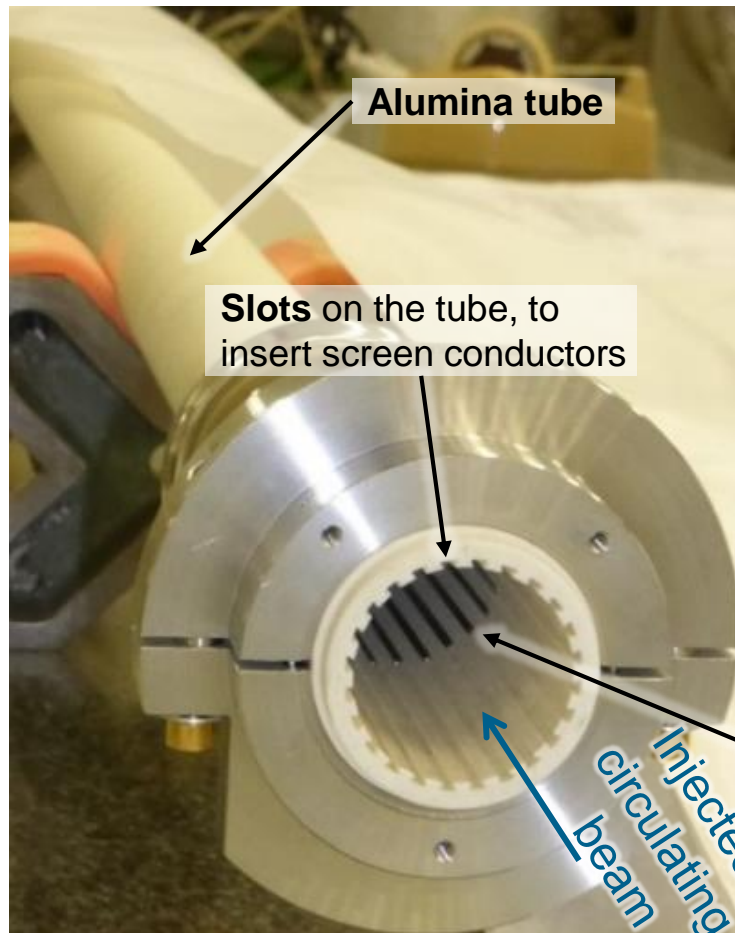
Planning of MKI cool installation

1 MKI cool (proto)	2 MKI cools	2 MKI cools	2 MKI cools	1 MKI Cool
YETS 22/23	YETS 23/24	YETS 24/25	Start of LS3	During LS3

1. Context

Screen conductors inside MKI

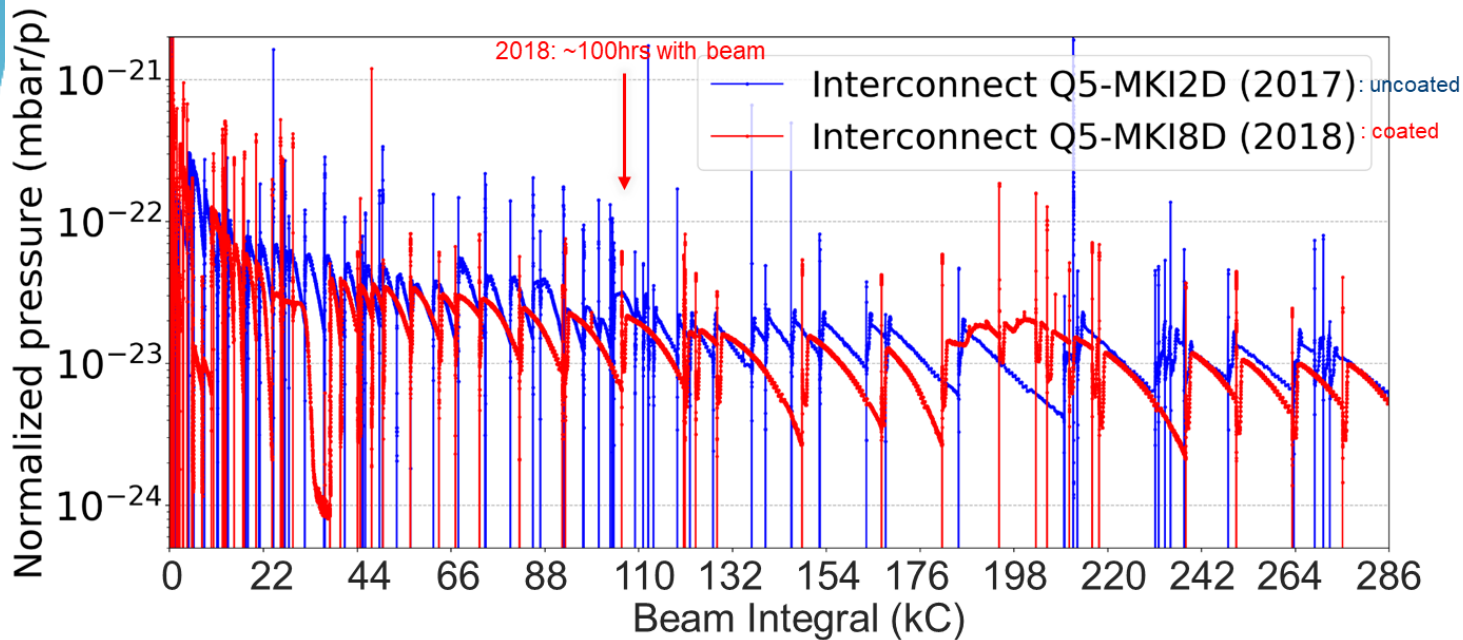
- Screen conductors **carry image current of circulating beam**
 ⇓
- **Lower beam induced heating**
- Conductors are **supported** and electrically insulated **by alumina tube** (high SEY)
- 2017-18 YETS upgrade of MKI8D: Alumina **tube is coated on the inside with Cr_2O_3** : has a **low SEY**, does not produce UFOs and is high voltage compatible



24 screen conductors
(one each 15 degrees, since LS1)

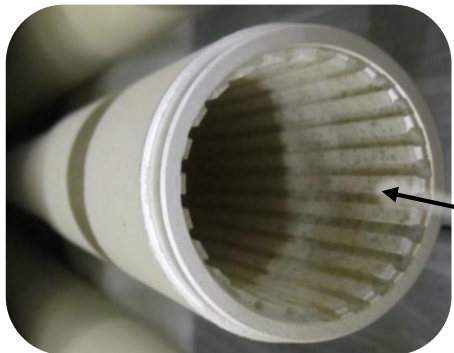
1. Context

Cr₂O₃ coating in MKI8D, installed in YETS 17-18



- **Before:**
Pressure in MKI8D interconnect used to be a factor of **~3** (2012, 2015 and 2017) and **~12** (2016) **higher than that of Q5-MKI2D**

- **After:**
This factor is not observed anymore.
No other vacuum modifications were done, **so pressure reduction is attributed to Cr₂O₃ coating** 👍

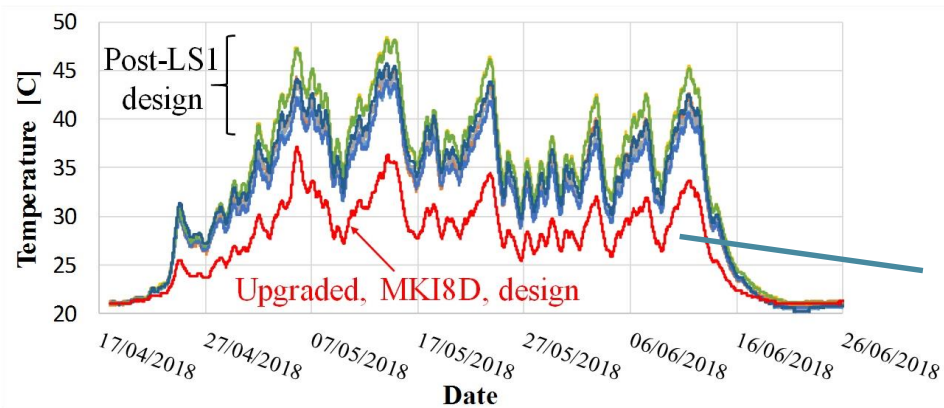
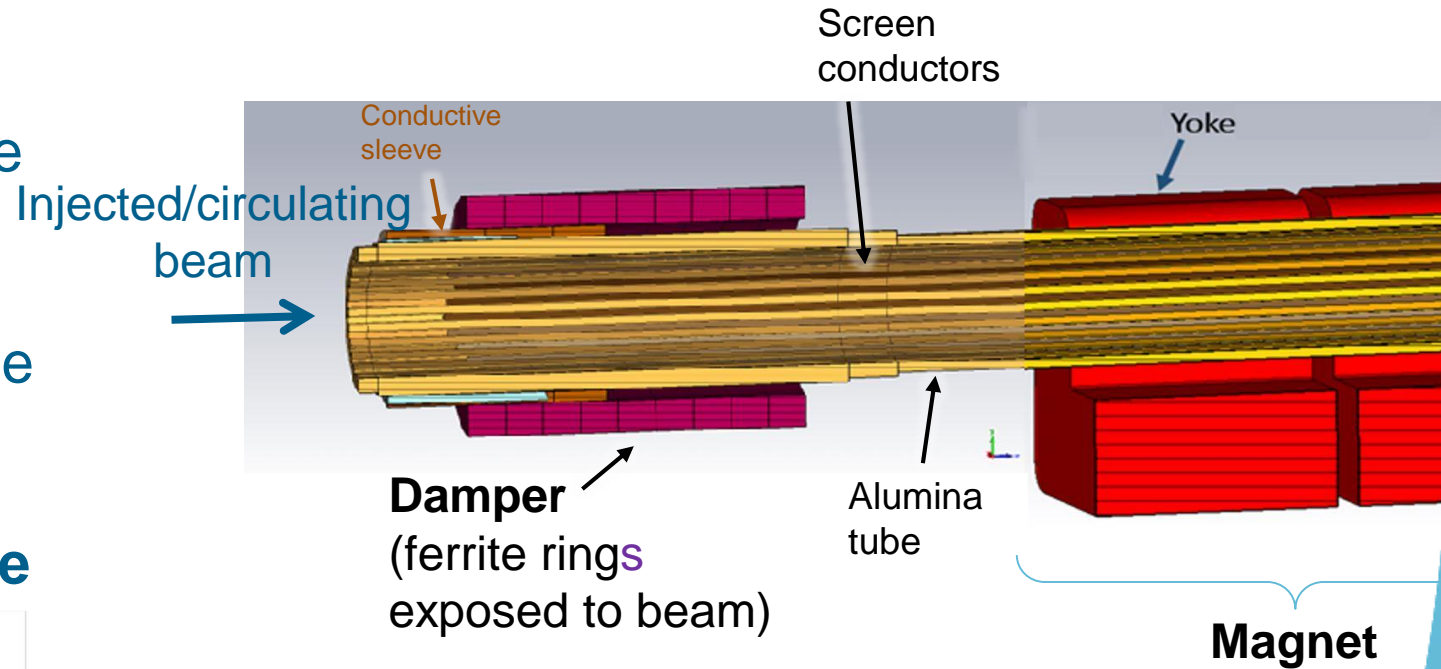


Alumina tube with **Cr₂O₃ coating** on the inside

1. Context

Damping element: the origin of MKI cool

- Redesigned **ferromagnetic rings (damper)**, placed on the alumina tube outside of the magnet aperture, **re-locates beam induced power deposition** from the ferrite yoke to the damper
- Damper is **not at pulsed high voltage**

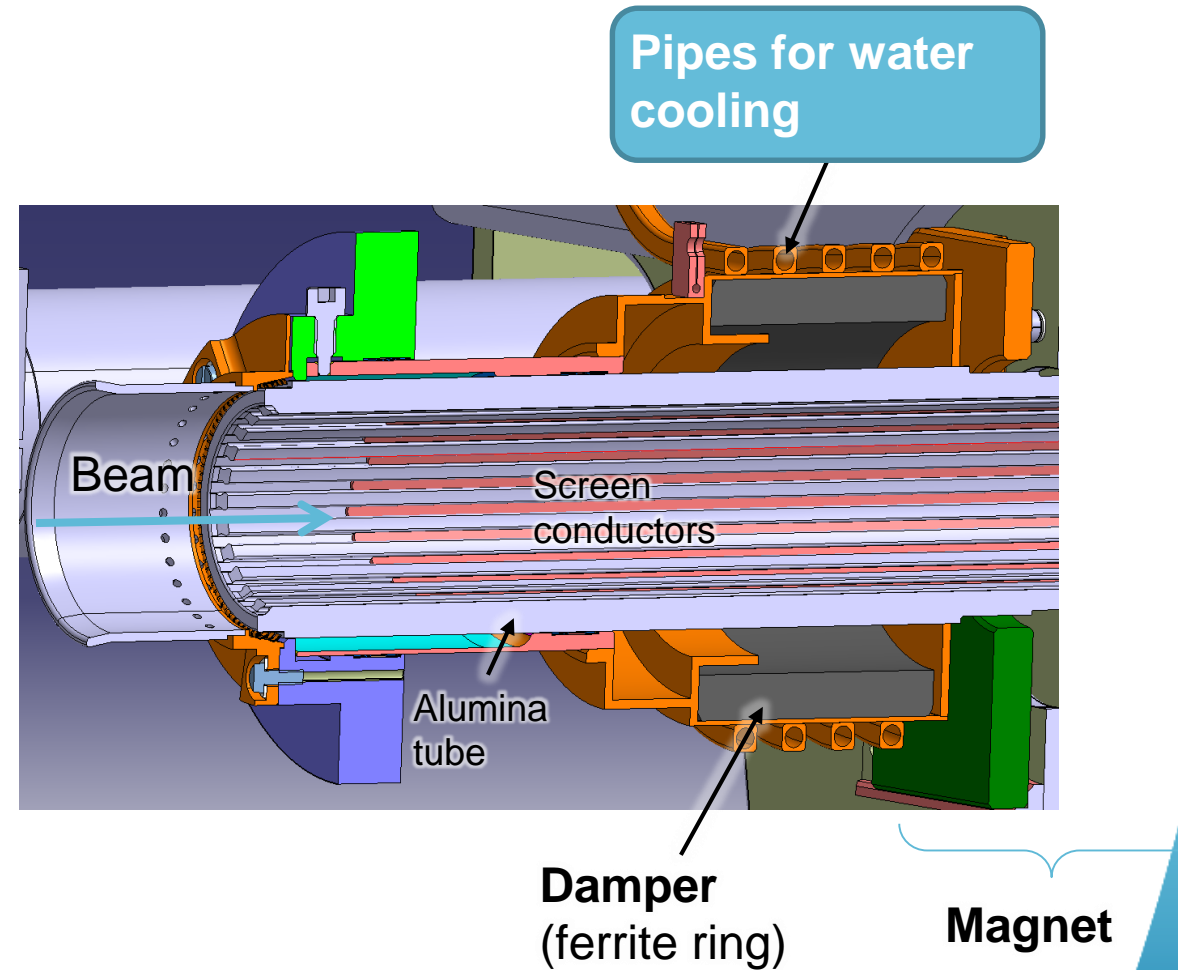


Reduced heating of ferrites

1. Context

MKI cool = damping element + water cooling

- **Damping element fulfils** the function of **re-locating** beam induced **power**
- **BUT, with HL-LHC beam**, it would reach the Curie temperature, and (temporarily) **stop working**
- The idea of the **MKI cool** is to cool the damper with **water** to remove heat



2. Issues – now solved During 2019

Non-conformity of slots in alumina tubes purchased during 2017: slots were too wide. Thus, it was necessary to use **screen conductors** with a small **zig-zag**

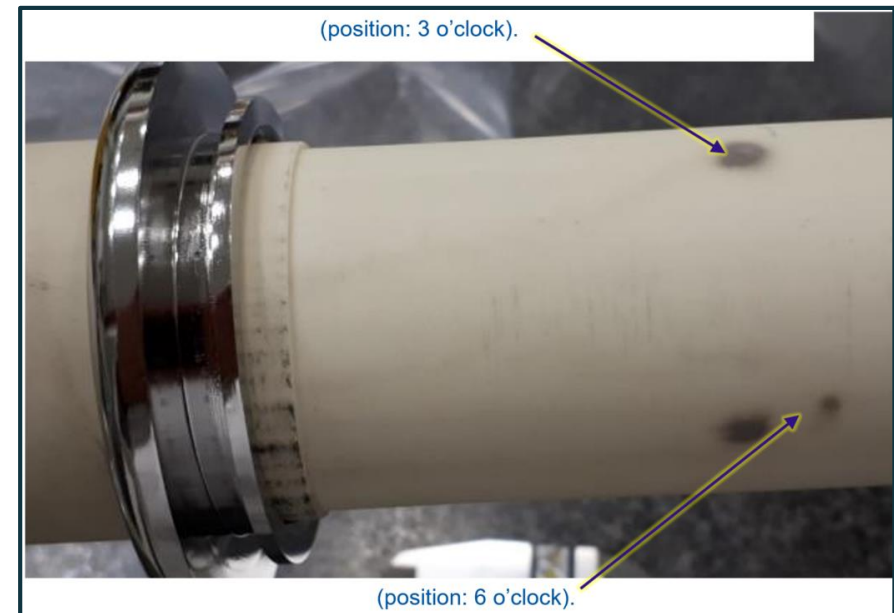
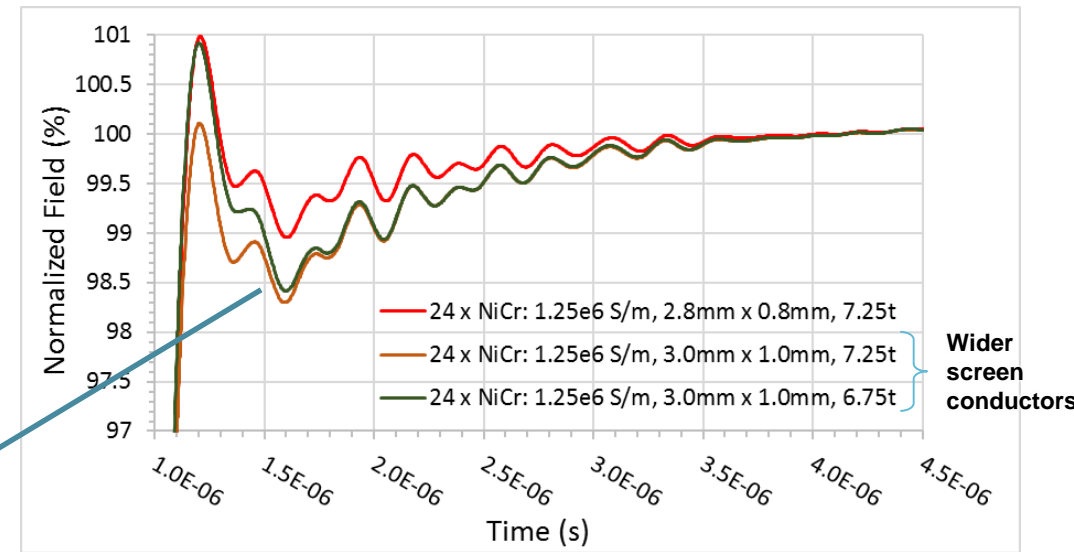
[HL-NCR: <https://edms.cern.ch/document/2440015/1.0>]

Using wider screen conductors was discarded due to influence on magnetic field (eddy currents)

HV pre-conditioning of MKI cool failed:

[HL-NCR: <https://edms.cern.ch/document/2440015/1.0>]

- 18 **strong sparks** occurred over two weeks
- **Conditioning plateaued at ~45kV (goal=56.1kV)**
- Three **black marks** from HV **breakdowns** to alumina tube

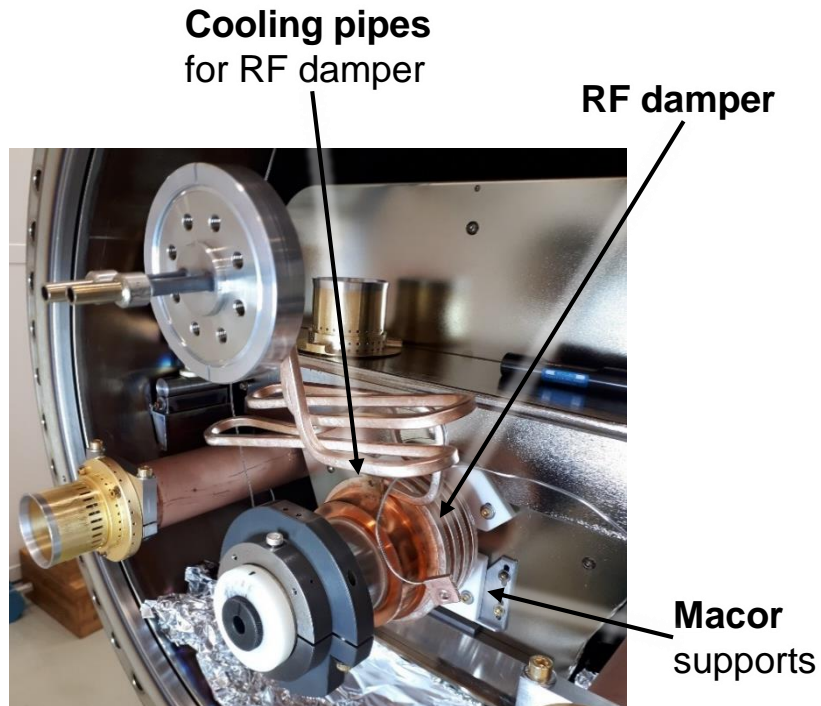


2. Issues – now solved

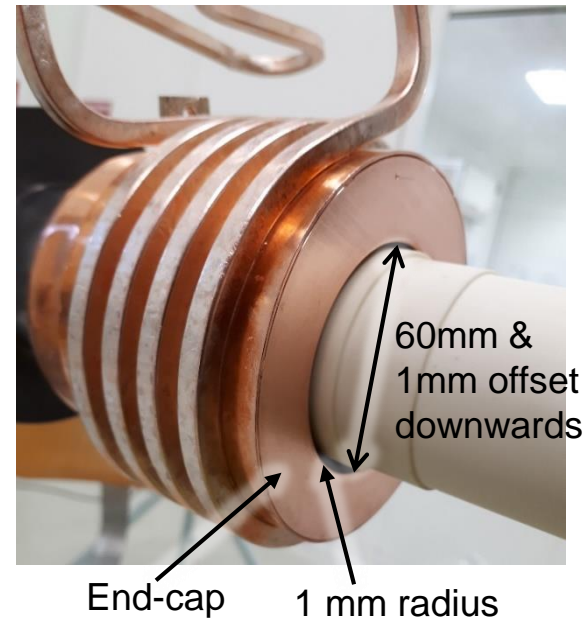
During 2019. Actions carried out

RF damper structure was modified to mitigate HV breakdowns:

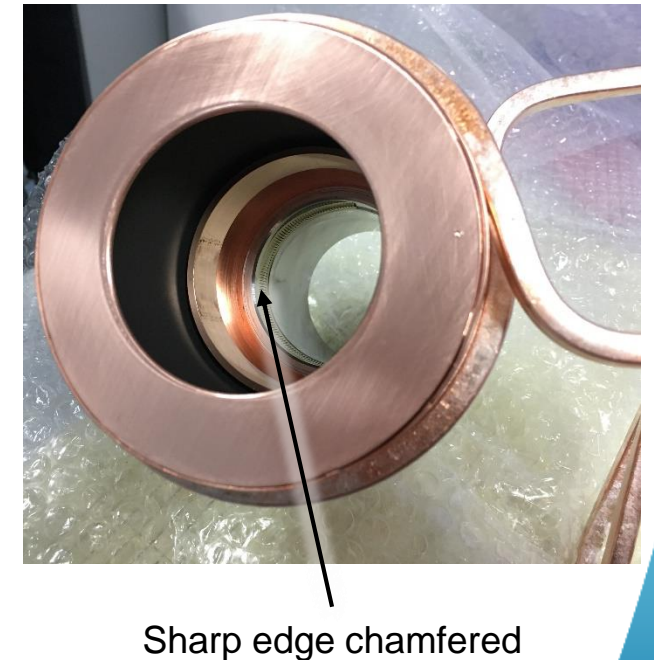
1. Metal **supports** for **tube** replaced by **macor**



2. RF damper end cap inside diameter enlarged (from 56mm to 60mm), to increase distance to alumina tube



3. **Sharp edge** on stainless steel short eccentric tube removed (manufacturing error)



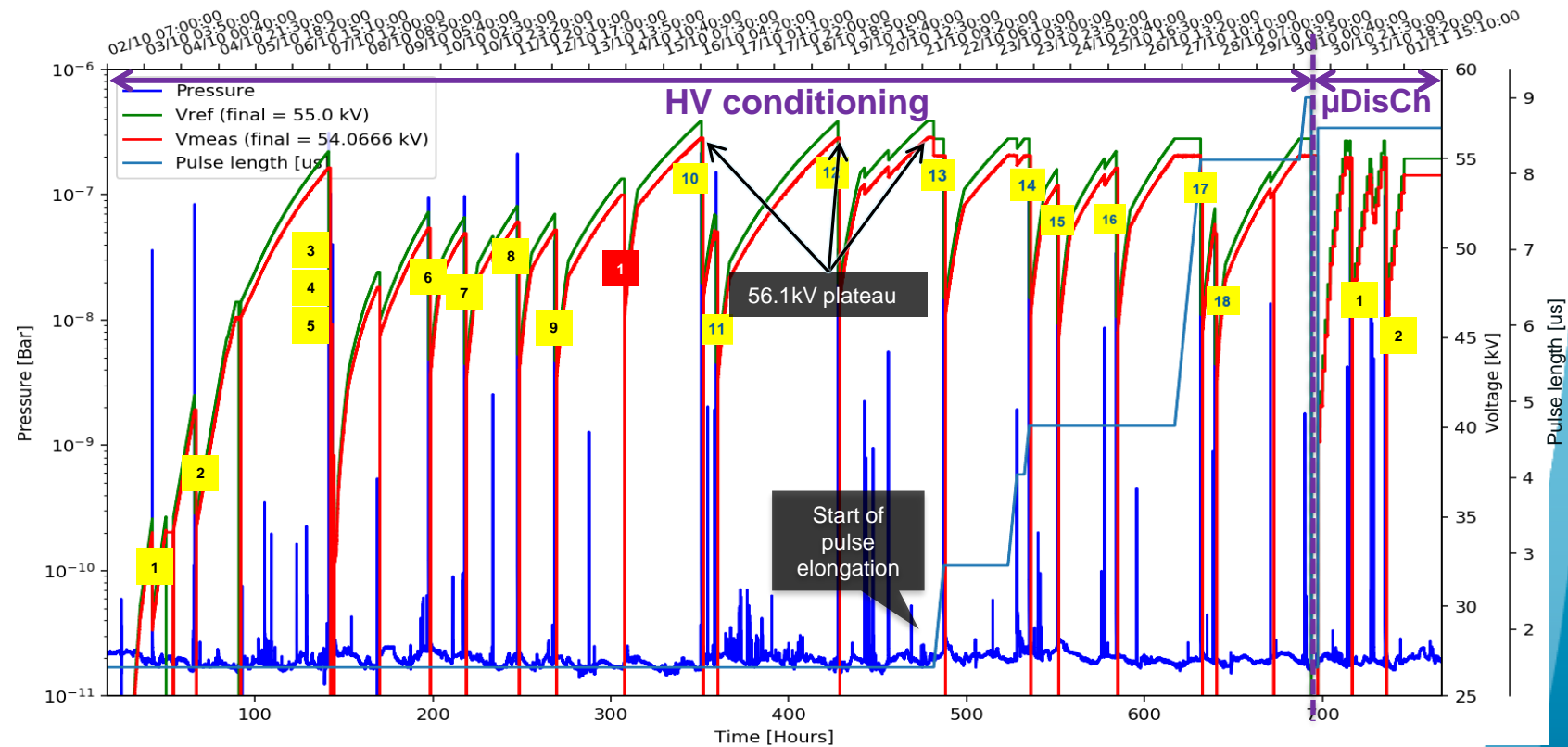
2. Issues – now solved

During 2020. HV conditioning

Conditioning **completed** and **target of 56.1kV*** and 8.8 μ s flattop reached,
BUT:

- Conditioning **required 230k pulses** (usually 50k to 100k)
- **18 strong sparks** were observed (usually <6)
- For the first time, **two strong sparks** during **micro-discharge** test
- Hence, magnet was **not installed**, but opened and **inspected** instead

N System reset
N Strong spark

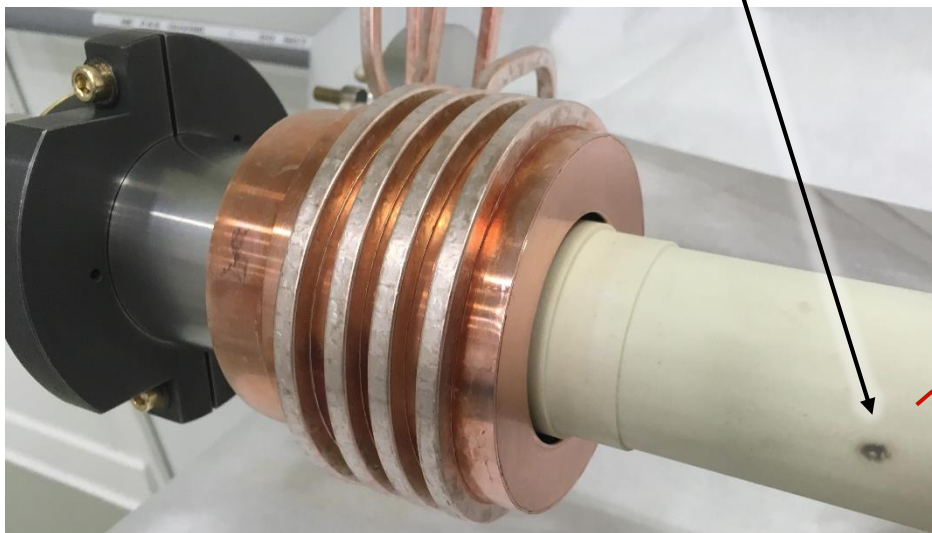


*: 56.1kV is ~10 % above Point 8 operational voltage (51.3kV)

2. Issue – now solved

Inspection after conditioning (November 2020)

First observation: Still one **black mark** seen **on the tube**, at the end (3 marks in 2019)

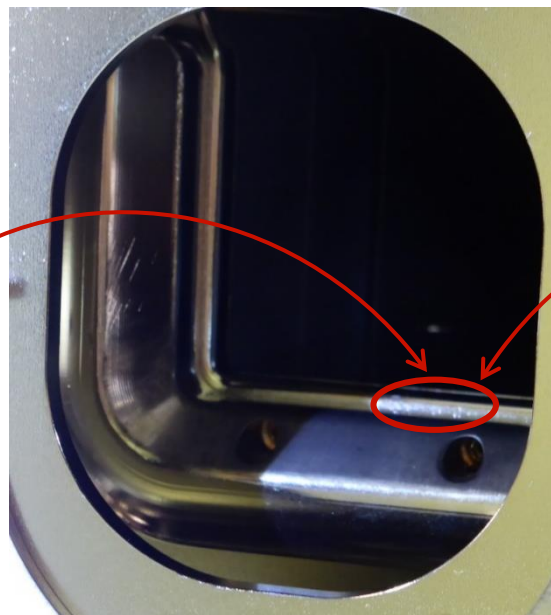


Alumina tube **outside of magnet**

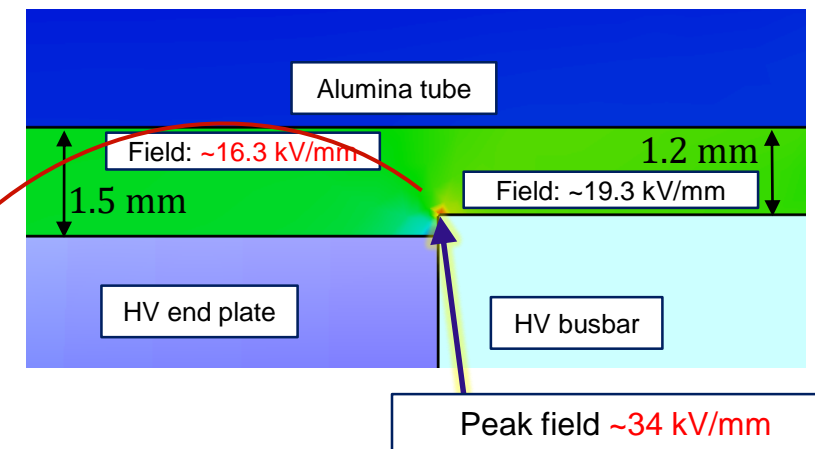
The **reason** was a **sharp edge** due to **misalignment of HV busbar** of the magnet



Solved with correct alignment



End of magnet, **without tube**

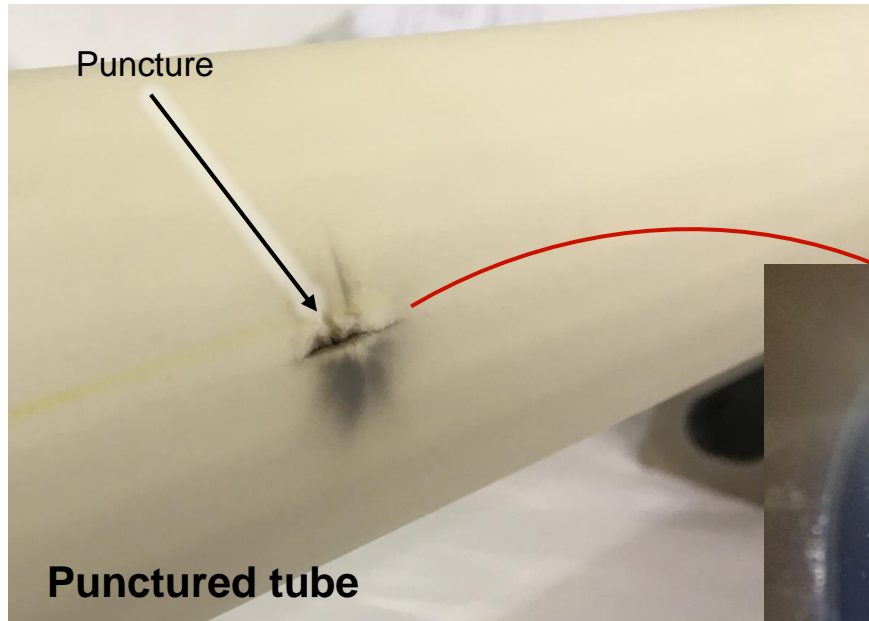


Enhanced electric field (~doubled) **due to dealignment** of HV busbar

3. Issue – understood

Inspection after conditioning (November 2020)

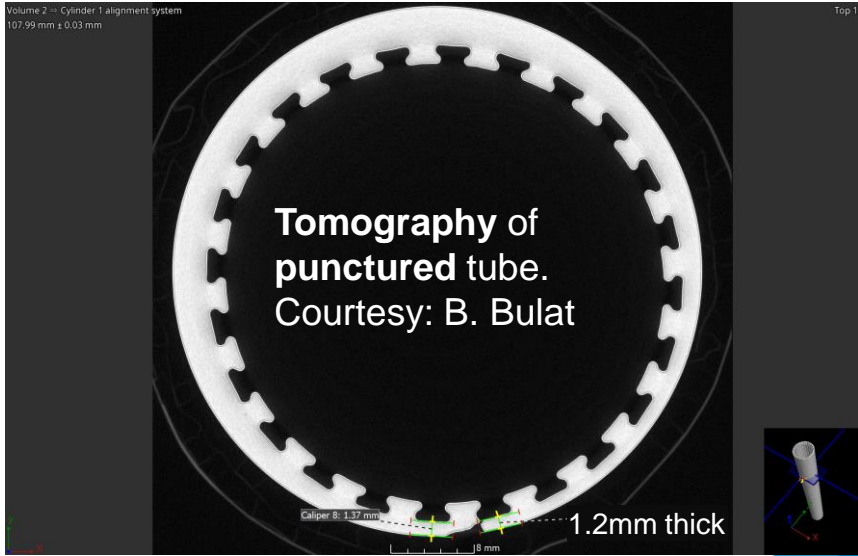
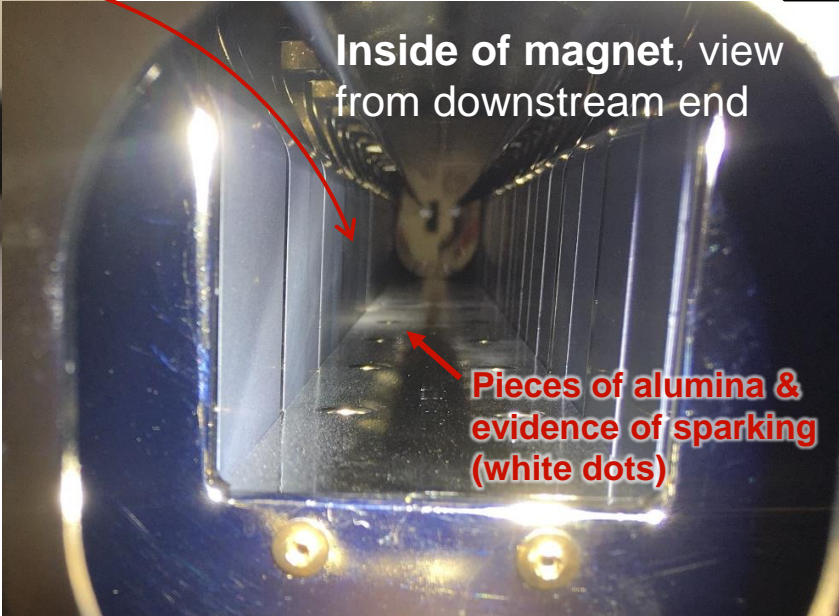
Second observation: alumina tube was **punctured**, inside of the **magnet** (52cm from downstream end)



Reasons of puncture:

High voltage difference during pulse

Tube extremely thin at that position (mis-manufactured)

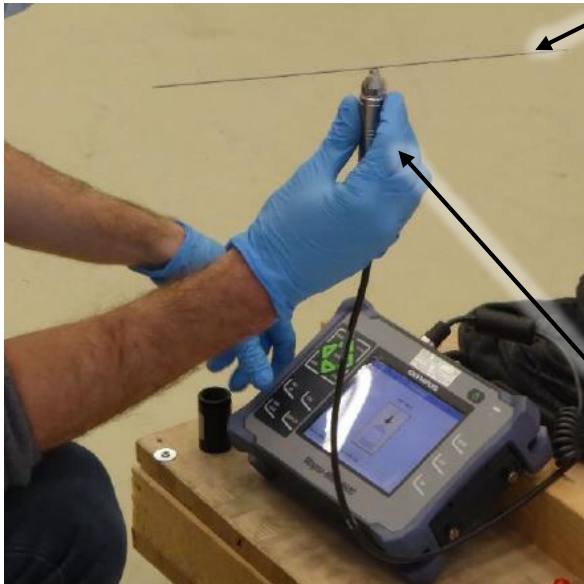


3. Issue – understood: mis-manufactured alumina tubes

Puncture triggered study of tube thickness of 2017 batch

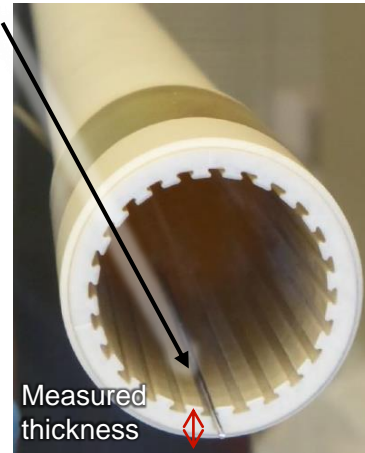
All 2017 tubes were measured

Magnetic gauge measures wall thickness all along the tube



Magnetic rod

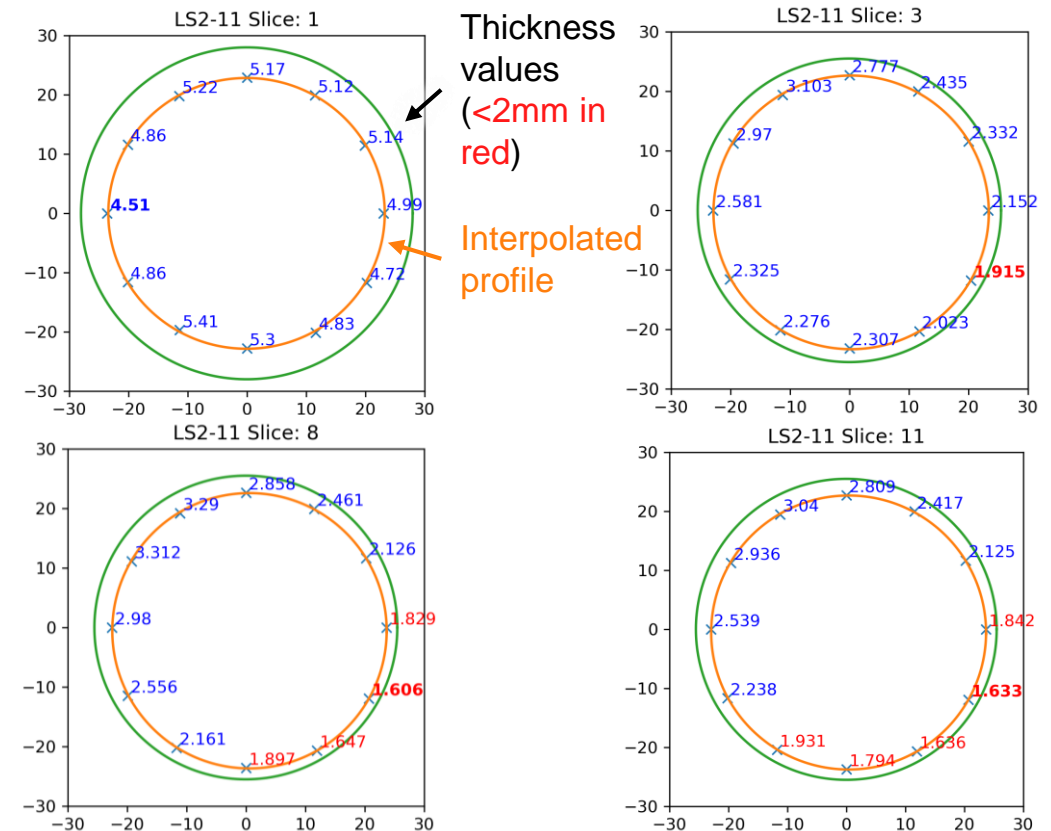
Probe connected to device



Measured thickness



A dedicated Python programme was developed, to show the inner profile of the tubes



3. Issue – understood: mis-manufactured alumina tubes

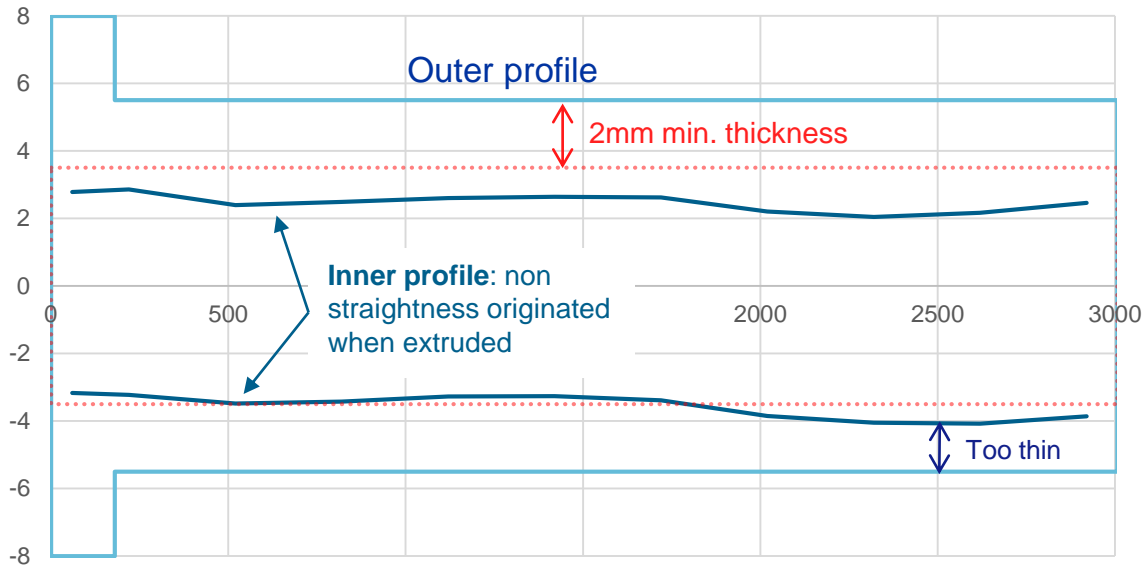
Discussions with manufacturer + conclusions of study

For manufacturing, tube is **extruded with final inner profile**, but larger outer diameter

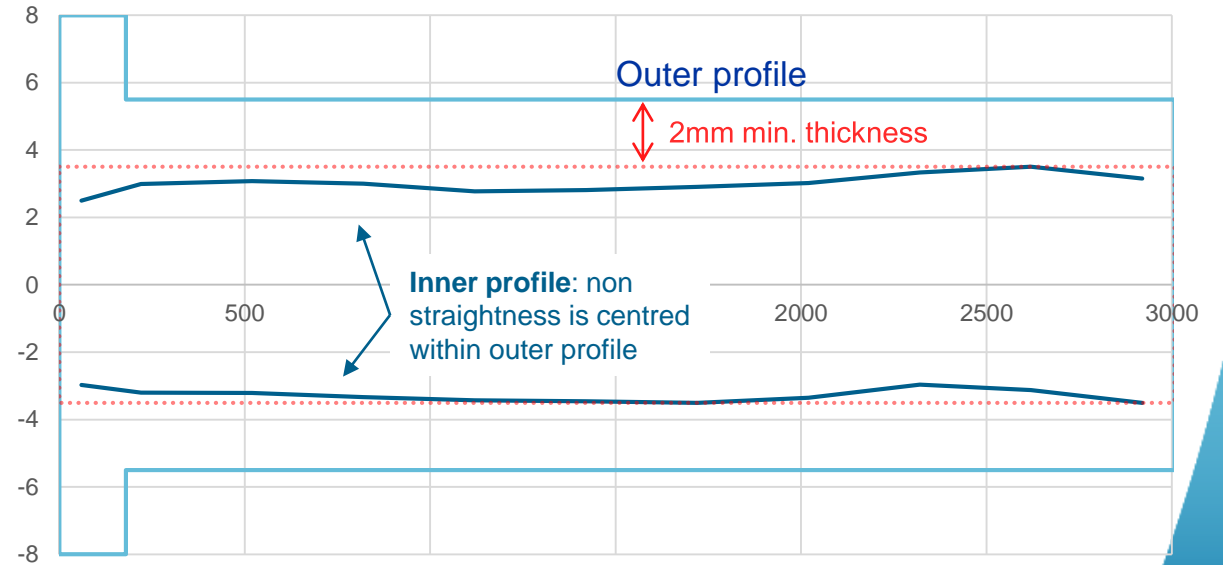
Afterwards, the **outside surface is machined**

1. **No tubes, from 2017 batch, with required minimum wall thickness (2mm)**
2. **Axis for machining the tube could be better chosen, to have more uniform wall thickness**

Longitudinal **profile** of tube (LS2-11)



Theoretical **optimal machining** (LS2-11)

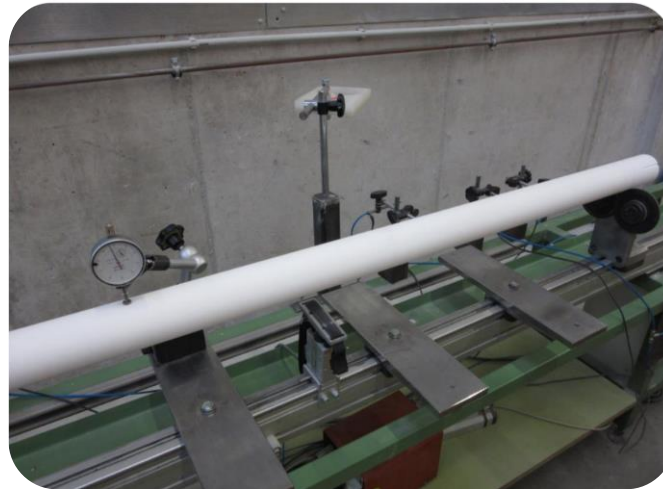
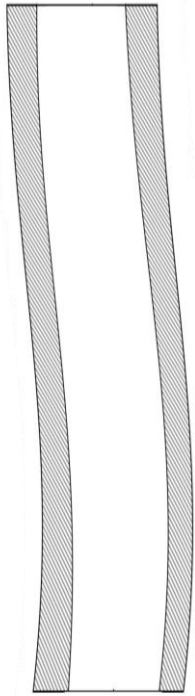


3. Issue – understood: mis-manufactured alumina tubes

Current work: determining the optimal machining axis

Shape of tube after extrusion is imperfect

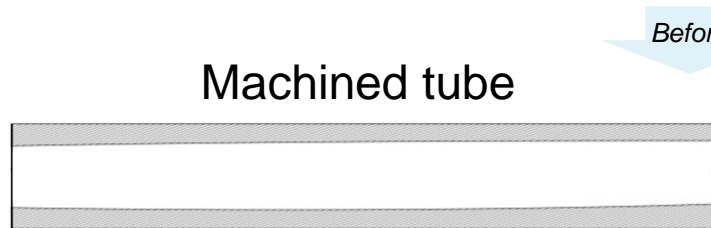
Extruded tube
(exaggerated deformation)



Outer profile characterisation



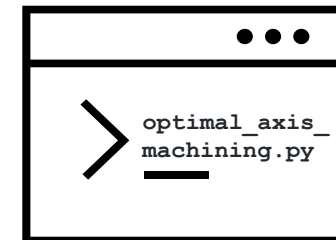
Wall thickness measurement
(before machining)



Before



Optimal axis for machining
 $= \{x_1, y_1, x_2, y_2\}$

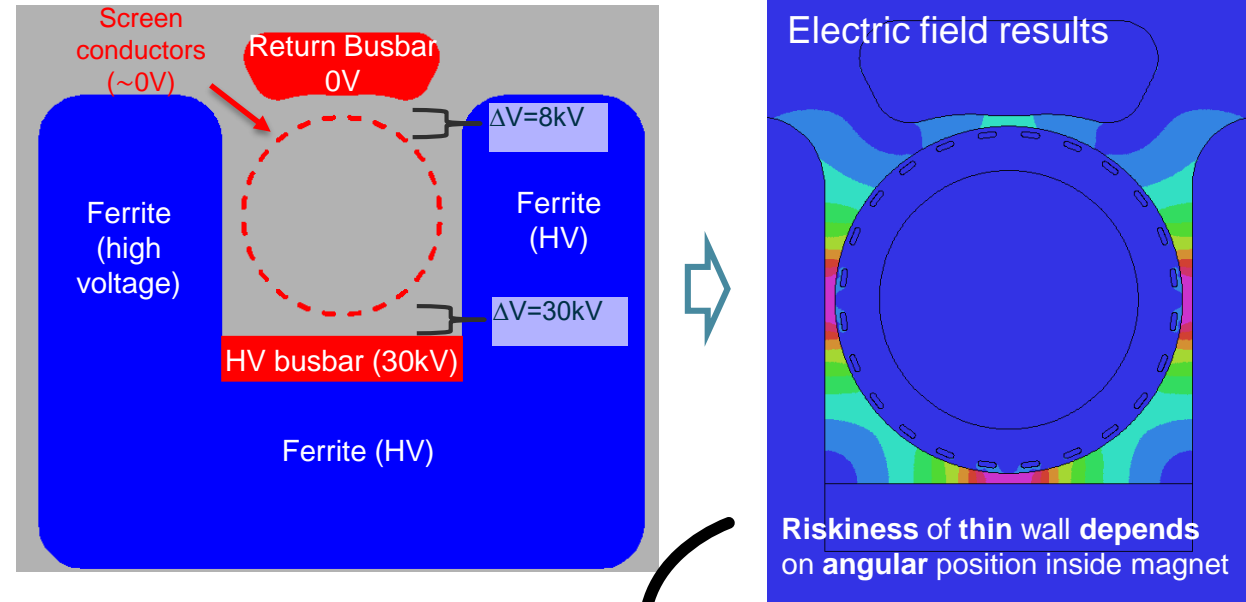


Future

3. Issue – understood: mis-manufactured alumina tubes

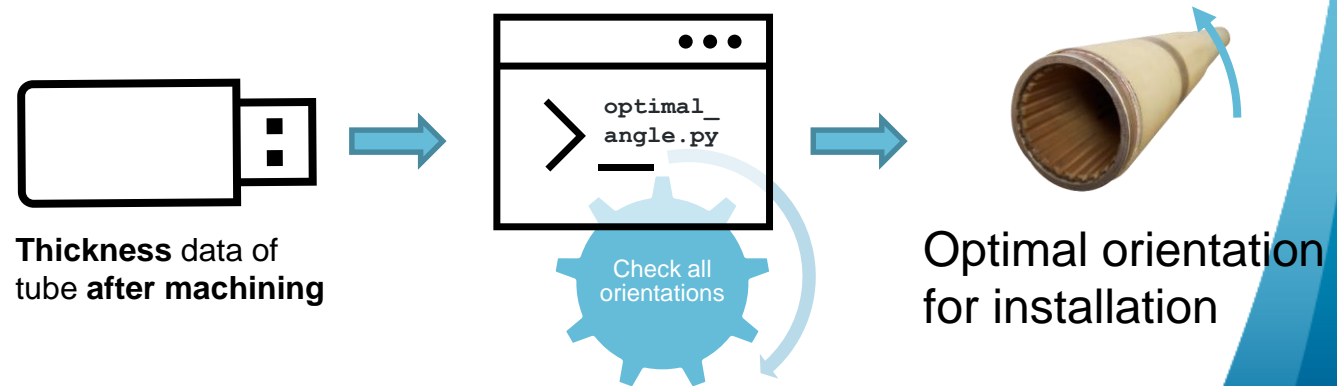
Optimization of tube rotational angle for installation

- **Angle** for installing of the tube **can be chosen**
- **Electric field data**, predicted by **simulations**, depends on:
 - Wall **thickness** of the tube (d)
 - **Angular position** of screen conductor (θ)
- **Python** programme to check every orientation (0, 15, ... 345 deg.) and calculate electric field
- **Orientation** with lowest E field is chosen for installation



$$E_{\theta,d} = f(\theta, d)$$

Minimised risk of breakdown



4. Status of first MKI cool to be installed in LHC

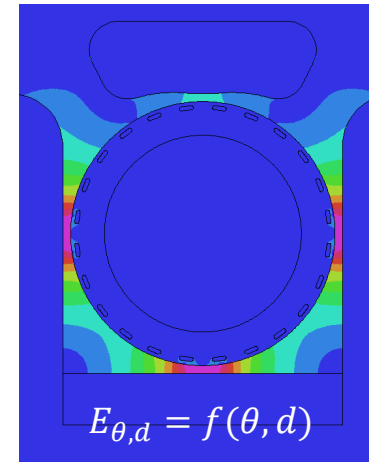
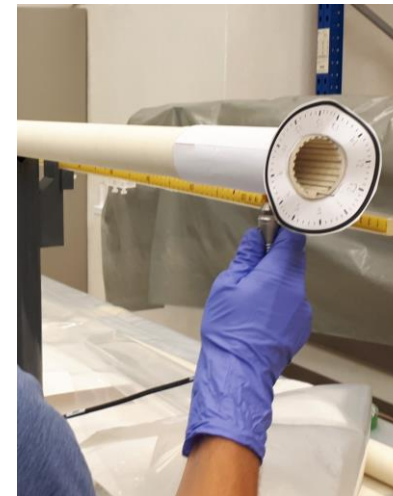
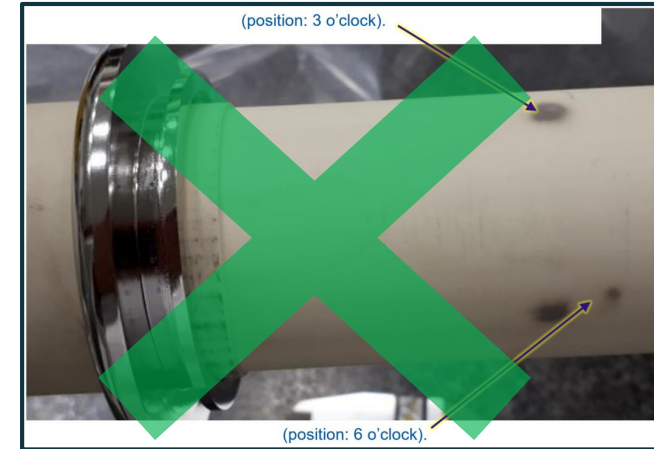
- **Installation** planned for **YETS 22/23**
- **Successful HV pre-conditioning**
- **Planning** has been **delayed** due to a **vacuum leak**.
The **seal** is being replaced.
But still in schedule, for **YETS 22/23**,
at location **MKI8C**



MKI cool in test cage

5. Conclusions

- **High voltage issues** during 2019 and 2020 have been **successfully solved**
- The **remaining issue** is the **risk** of puncture due to **non-conforming alumina tubes**:
 - The issue is well **understood** and a there is good **collaboration** with the manufacturer
 - **Detailed measurements** of the tubes prior to machining will result in achieving minimum of 2mm wall **thickness**
 - **Remeasuring** the tubes after machining will **validate correct machining**, and therefore **thickness**
 - **Optimizing angular position**, for installation in an MKI, will serve as an extra **protection** against HV breakdowns through the tube wall



Thanks for your attention !

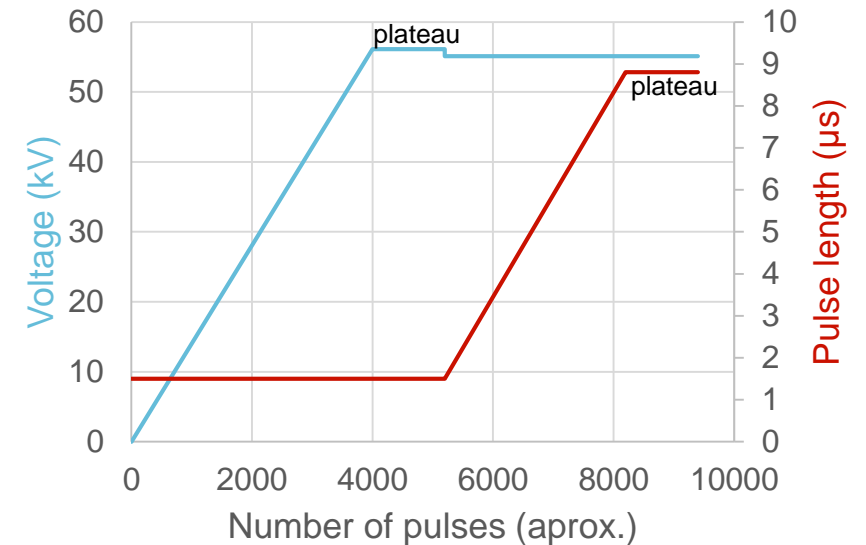
Spare slides

Context

MKI conditioning information

- Operational voltage of MKIs is 49.6 kV at Point 2 and 51.3 kV at Point 8
- All MKIs are conditioned to ~10 % above Point 8 voltage = 56.1 kV
- During HV conditioning:
 - Voltage is ramped up to 56.1kV at a fixed pulse length of 1.5 μ s;
 - Ramping is followed by a plateau (1.5 μ s at 56.1kV for 1200 pulses);
 - Plateau is followed by enlarging mode (1.5 μ s to 8.8 μ s) at 55.1kV;
 - Finally, a plateau with 8.8 μ s at 55.1kV for 1200 pulses
- HV conditioning is followed by a micro-discharge test, for validating the MKI:
 - Voltage is quickly ramped up to 55kV* at a fixed pulse length of 8.6 μ s, 500 pulses per step
- Notes:
 - *: 1 kV above the maximum SoftStart PFN voltage at Point 8
 - A pressure rise is considered a micro-discharge (energy dissipated in the magnet or beam screen is relatively low) when the pressure takes a few minutes (e.g. 3 minutes) to recover to its pre-breakdown level.

Simplified conditioning schematic



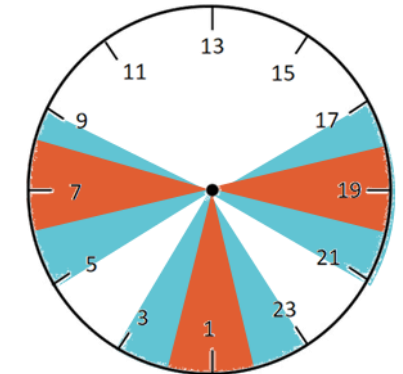
Alumina tube measurements summary

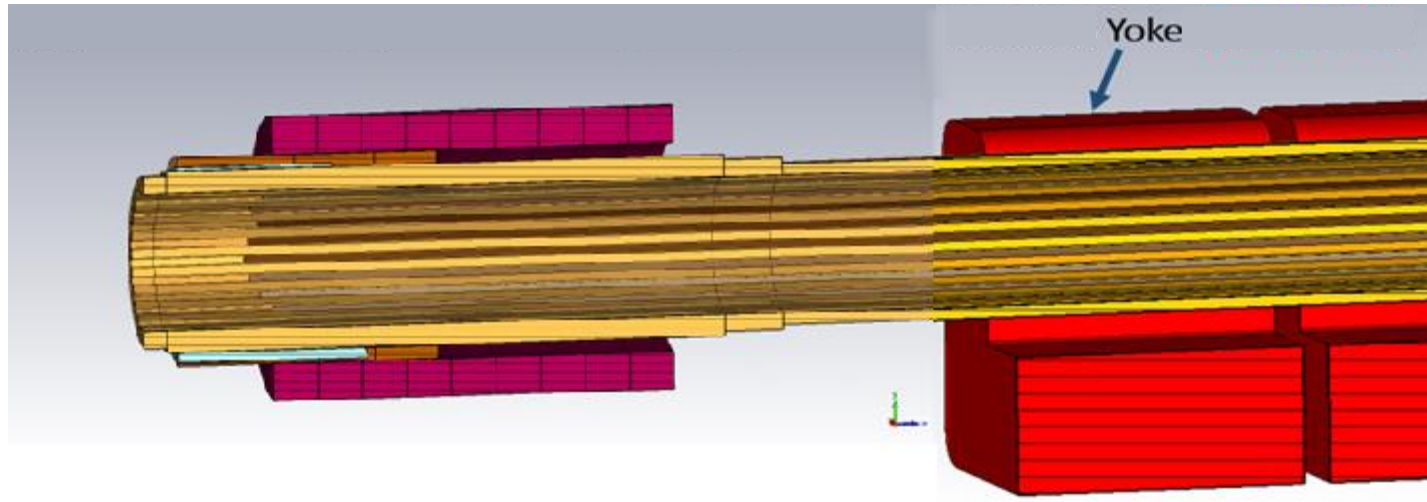
Tube	Absolute minimum thickness (mm)	Longitudinal position (cm) of the minimum thickness (starting from Ø56mm end)	Average hole radius (mm)	Average offset of centre of hole (mm)	Relaxed criteria		Exigent criteria	
					Thinnest point on critical angles ($\pm 15^\circ$ inc.) after optimization (mm)		Thinnest point on critical angles ($\pm 30^\circ$ inc.) after optimization (mm)	
Old tubes								
MKI2B	1.98	112	22.85	0.43	2.24	2.24	2.24	2.24
LS1-1	1.75	22	22.93	0.27	2.25	2.25	1.955*	1.955*
LS1-2	1.36	202	22.96	0.82	1.75	1.75	1.48	1.48
LS1-3	2.04	112	22.86	0.39	2.39	2.39	2.39	2.39
New tubes								
LS2-1	1.23	52	23.12	0.71	1.79	1.79	1.65	1.65
LS2-2	0.95	202	23.23	0.68	1.64	1.64	1.25	1.25
LS2-3	1.44	232	23.11	0.42	1.72	1.72	1.72	1.72
LS2-4	1.42	232	23.09	0.57	1.82	1.82	1.82	1.82
LS2-5	1.68	82	23.12	0.52	1.84	1.84	1.84	1.84
LS2-6	1.15	262	23.08	0.51	1.85	1.85	1.56	1.56
LS2-7	1.04	262	23.08	0.91	1.32	1.32	1.18	1.18
LS2-8	0.78	262	23.08	0.61	2.06	2.06	1.36	1.36
LS2-9	0.93	202	23.08	1.06	1.21	1.21	1.00	1.00
LS2-10	1.34	262	23.07	0.65	1.62	1.62	1.34	1.34
LS2-11	1.43	262	23.12	0.49	2.04	2.04	1.61	1.61
LS2-12	0.82	262	23.08	0.59	1.93	1.93	1.45	1.45
LS2-13	0.70	262	23.13	0.91	1.16	1.16	1.16	1.16
LS2-14	0.98	262	23.11	0.52	2.06	2.06	1.35	1.35
Number of good tubes					(2 of 3 2013 + 3 of 14 2017)	(2 of 3 2013 + 0 of 14 2017)	= 5	=2

Notes:

LS1-? = 2013 batch

LS2-? = 2017 batch

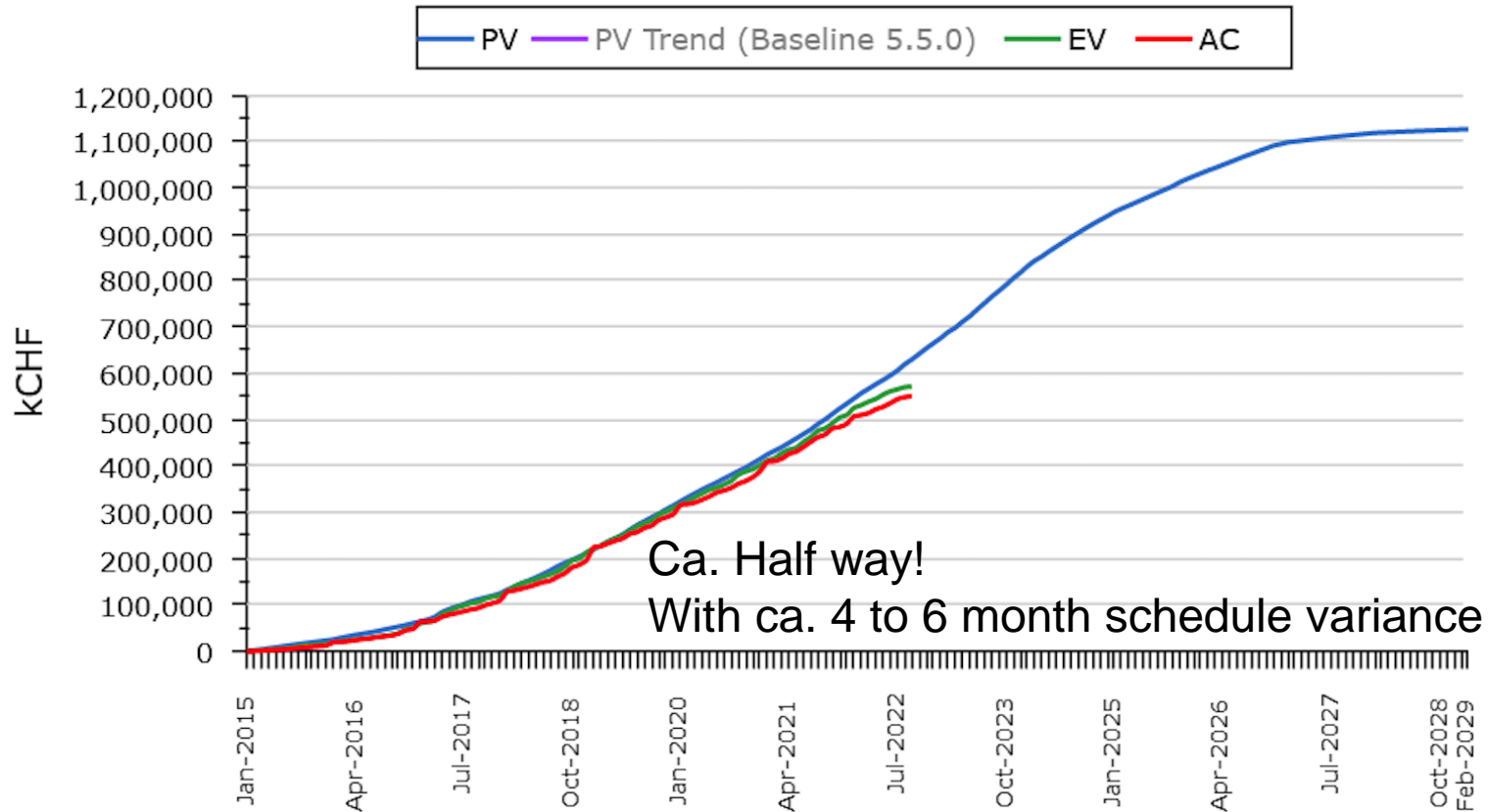




Reminder of the HL-LHC Goals

From FP7 HiLumi LHC Design Study application in 2010

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